OCT 1 4 2003 09862.022072.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	••	:	Examiner: N. Wells
MASATO MURAKI ET AL.)	
		:	Group Art Unit: 2881
Application No.: 09/733,980)	
		:	
Filed: December 12, 2000)	
		:	
For:	CHARGED-PARTICLE BEAM)	
	EXPOSURE APPARATUS,	:	
•	CHARGED-PARTICLE BEAM)	
	EXPOSURE METHOD, CONTROL	:	
	DATA DETERMINATION)	
	METHOD, AND DEVICE MANU-	:	
	FACTURING USING THIS)	
	METHOD	:	October 9, 2003
Mail	Stop RCE		
Commissioner for Patents			
P.O. Box 1450			

PRELIMINARY AMENDMENT

Sir:

Alexandria, VA 22313-1450

A Request for Continued Examination is filed concurrently herewith.

Preliminary to continued examination, please amend the above-identified application as follows.

The claims are listed beginning at page 2. The Remarks begin at page 11.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 9, 2003.

(Date of Deposit)

FRANK A. DeLUCIA, JR. (REG. #42,476)
Name of Attorney for Applicant)
October 9, 2003

gnature

Date of Signature